## Supporting Information

## Hierarchical NiO/CMK-3 Photocathode for a $p$-Type Dye-Sensitized Solar Cell with Improved Photoelectrochemical Performance and Fast Hole Transfer

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Figure S1. The structure of the PMI-6T-TPA sensitizer.


Figure S2. Schematic illustration of the synthetic process of the Ni-Precursor/CMK-3.


Figure S3. (a) XPS survey scan of NiO/CMK-3 composite; (b) C1s XPS spectrum of $\mathrm{NiO} / \mathrm{CMK}-3$ composite.


Figure S4. Short-circuit IMPS response (a), (c) and IMVS response (b), (d) for NiO/CMK-3 and NiO cluster, respectively.


Figure S5. Fitted EIS plot of p-DSSCs made of two nanomaterials and the insert is calculated parameters.

Table S1. The fitting errors of corresponding EIS parameters.

| Sample | $\mathbf{R}_{\mathbf{p t}} \mathbf{( \% )}$ | $\mathbf{R}_{\mathbf{t}} \mathbf{( \% )}$ | $\mathbf{R}_{\text {rec }} \mathbf{( \% )}$ | $\mathbf{R}_{\mathbf{s}} \mathbf{( \% )}$ | $\mathbf{C}_{\boldsymbol{\mu}} \mathbf{( \% )}$ |
| :--- | :--- | :--- | :--- | :--- | :---: |
| $\mathrm{NiO} / \mathrm{CMK}-3$ | 0.17 | 3.94 | 5.02 | 0.21 | 4.79 |
| NiO cluster | 1.46 | 0.73 | 2.86 | 0.47 | 5.24 |

